

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/566,116 Confirmation No. 3700
Applicant : Akihisa Inoue et al.
371 Filed : January 24, 2006
Art Unit : 1742
Examiner : Weiping Zhu
Customer No. : 00270
Title : SPUTTERING TARGET AND METHOD FOR PRODUCTION
THEREOF

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment submitted with a Request for Continued Examination (RCE). It is in response to the FINAL Office Action dated April 30, 2007. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.